Notice of Allowability	Application No.	Applicant(s)	
	10/808,827	PRASAD, ABANESHWAR	
	Examiner	Art Unit	
	Robert Scruggs	3723	
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED or other appropriate comm GHTS. This application is	in this application. If not including in this application. If not including the mailed in due	led course. THIS
1. X This communication is responsive to <u>1/9/07</u> .	•		
2. The allowed claim(s) is/are <u>1-4 and 7-23</u> .			
3. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received:	been received. been received in Applicati	on No	ation from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the re	equirements
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			NOTICE OF
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) ☐ including changes required by the Notice of Draftspers		ew (PTO-948) attached	•
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment o	or in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			e back) of
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT			Note the
			·
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. \(\sum \) Notice of I	nformal Patent Application	
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview	Summary (PTO-413),	•
3. Information Disclosure Statements (PTO/SB/08),		./Mail Date s Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner' 9. □ Other	s Statement of Reasons (1) All)N
		PRIMARY EXAM	INER

DETAILED ACTION

1. This office action is in response to the amendment received on January 9, 2007. Applicant's arguments, see pages 2-5, filed January 9, 2007, I with respect to 1-4 and 7-23 have been fully considered and are persuasive. The rejection of claims 1-4 and 7-23 has been withdrawn.

Allowable Subject Matter

- 2. Claims 1-4 and 7-23 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: The present invention pertains to a polishing pad. It is the examiner's opinion that the art of record considered as a whole, alone or in combination, neither anticipates nor renders obvious of a hydrophobic region in combination with an endpoint detection port and a hydrophilic region, said hydrophobic region being formed adjacent to and completely surrounding the endpoint detection port, said hydrophobic region also having a surface energy of 34mN/m or less and said hydrophilic region having a surface energy more than 34mN/m, together in combination with the rest of the limitations or the independent claims.
- 4. The closest prior art is made of Lehman et al. (2003/0190864), Prasad et al. (6884156) and Prasad (7059936). Lehman et al. discloses a polishing pad having a polishing layer (188), a membrane (194) that completely surrounds an endpoint detection port (182) wherein said polishing layer and said membrane are formed from polyurethane. Prasad et al. (6884156) discloses a multi-layered polishing pad having optically transmissive material. Prasad (7059936) discloses a low surface energy-

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polishing pad including a hydrophobic repeating unit and a hydrophilic repeating unit where the entire polishing pad is formed with a surface energy of 34mN/m or less.

5. However, the prior art fails to disclose a hydrophobic region formed adjacent to and completely surrounding an endpoint detection port with a surface energy of 34mN/m or less in combination with a hydrophilic region having a surface energy more than 34mN/m.

Response to Arguments

- 6. Applicant's arguments have been fully considered and are persuasive.
- 7. Applicant's contends that, "despite the fact the alleged hydrophobic region and the alleged hydrophilic region both comprise the same material, i.e., polyurethane, the Office Action asserts that the hydrophobic region "can inherently be formed to have a surface energy of 34mN/m or less depending upon the application" while the hydrophilic region "being formed from polyurethane... can inherently be formed to have a surface energy of 34mN/m or more depending upon the application. Thus, the disclosure of membrane 194 comprising polyurethane, regardless of its alleged ability to function as a sealant, fails to teach a hydrophobic region comprising a polymeric material having a surface energy of 34mN/m or less. As described in the specification, polyurethanes have a surface energy of 34mN/m or more (Para. 0019) and are hydrophilic as defined by the pending claims. It is generally recognized in the art the polyurethanes have higher surface energy values, and polyurethane has a surface energy of 45mN/m. See D.B. James, "CMP Polishing Pads" (Chapter 6) in Chemical-Mechanical

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Planarization of Semiconductor Materials (Springer, 2004), p. 169. Applicant is unaware of any conventional polyurethanes having a surface energy of 34nM/m or less."

a. The examiner agrees with the statements made above. It would not be inherent to make different regions of the polishing pad formed with different surface energies since both regions are formed with the same material (i.e. polyurethane).

Conclusion

8. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Robert Scruggs whose telephone number is 571-272-8682. The examiner can normally be reached on Monday-Friday, 8:30-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Joseph Hail can be reached on 571-272-4485. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.